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	305916	RAJ-012

**INFORMATION DISCLOSURE STATEMENT
BY APPLICANT**

Applicant: YAMASAKI et al.	
Appln. No.: 10/673,648	
Filing Date: September 30, 2003	
Examiner: Berry, R.R.	Group Art Unit: 2818

Date: January 5, 2005

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U.S. PATENT DOCUMENTS

Examiner's Initials*		Document Number	Date MM/YYYY	Name (Family Name of First Inventor)	Class	Sub Class	Filing Date (if appropriate)
<i>MP</i>	AR	6,444,263 B1	09/2002	Paranjpe et al.	427	250	
	BR						
	CR						
	DR						
	ER						
	FR						
	GR						
	HR						
	IR						
	JR						
	KR						
	LR						

FOREIGN PATENT DOCUMENTS

		Document Number	Date MM/YYYY	Country	Inventor Name	English Abstract		Translation Readily Available	
						Enclosed	No	Enclose	No
	MR								
	NR								
	OR								
	PR								
	QR								
	RR								
	SR								
	TR								
	UR								
	VR								

OTHER (Including in this order Author, Title, Periodical Name, Date, Pertinent Pages, etc.)

<i>MP</i>	WR	Kaplan et al., "The Deposition of Molybdenum and Tungsten Films from Vapor Decomposition of Carbonyls," Journal of the Electrochemical Society USA, Vol. 117, No. 5, May 1970 (1970-05), pages 693-700			X
	XR				
	YR				
	ZR				

Examiner *RAJ* Date Considered: *2-4-05*

*EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.